

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Prior Application: S. NUMAZAWA et al  
Serial No. 10/325,915  
Filed: December 23, 2002

Group Art Unit 2825  
Examiner: B. Keshavan  
For: METHOD OF FABRICATING SEMICONDUCTOR  
DEVICE

**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

February 25, 2004

Sir:

Prior to examination, please amend the above application  
as follows.